

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 5377

Makiko KITAZOE, et al

Art Unit: 1712

Application No.: 10/591,905

Examiner: Keath T. CHEN

Filed: November 6, 2006

Attorney Docket No.: 029567-00010

For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS
AND CLEANING METHOD THEREOF

RESPONSE UNDER 37 C.F.R. §1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 31, 2011

Sir:

This paper is submitted in reply to the June 3, 2011 Office Action.

Amendments to the claims being on page 2; and

Remarks begin on page 7.